Design Drivers for Direct Detection Dark Matter Searches





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Plan

- Briefest Theoretical Overview Ever!
- Interaction Processes and Experimental Design Drivers for Direct Detection
 - WIMPs: 6 GeV < M_{DM} < ~100 TeV
 - Light DM: 100 meV < M_{DM} < 6 GeV DM

– Ultralight DM: M_{DM} < 10 meV



Today: Continue to Search for WIMPs



Today: Dark Matter Mass Parameter Space



- M < 3 keV:
 - Axions, dark photons and other ultra-light bosons
- 3keV <M < 10 GeV
 - Assymetric Dark Matter Kaplan, Zurek et al: 0901.4117
 - Freeze In Hall, et al: 0911.1120
 - Dark Sectors

US Cosmic Visions: New Ideas in Dark Matter: 1707.04591

Dark Matter Detection

(not to scale)













Complementarity with Accelerators



BRN: Dark Matter Small Projects New Initiatives

Experimental Design Drivers for Direct Detection



Design Drivers for $M_{DM} > 10 \text{ GeV}$

M_{DM} > 10 GeV: Tiny, Tiny Rates



M_{DM} > 10 GeV: Coherent Elastic Scattering



Scatter coherently off all the nucleons in a nucleus: $R \propto A^2$ Design Driver #2: Heavy Nuclei

Big Idea: For both very heavy and very light mass dark matter, we're going to take advantage of coherence

M_{DM} > 10 GeV: Backgrounds



Design Driver #3: Minimal Radiogenic Backgrounds

- Characteristic Recoil Energy: O(10keV)
- Same recoil energy as radiogenic backgrounds



Get rid of the Hay



Use only radiopure materials and fabrication techniques

DEMO: Cloud Chamber

Go underground to shield detector from cosmic rays and their decay products



M_{DM} >10 GeV: Electronic Recoil / Nuclear Recoil Discrimination



Measure both scintillation light and ionization to distinguish nuclear recoils from electron recoils

M_{DM} >~ 10 GeV: Liquid Noble TPCs LZ (XENON 1T,PandaX)

- Exposure: (7 tons)
- High A: Xe

Electrons

- Underground
- Radioclean: self shielding
- Electronic/Nuclear Recoil Discrimination

More: Dan's talk next week

G2 High Mass Sensitivity Estimates





Design Drivers for 1 MeV < M_{DM} < ~6 GeV DM Scalar Interactions

Light Mass DM Design Drivers: Exposure ?



LZ needs 10 tons to get to 10⁻⁴⁷ cm² at 100GeV, Light Mass DM searches only needs 10kg to reach the same level at 100MeV

Kinematics: 2 Body Elastic Nuclear Scattering



$$K_n = \frac{\mu^2 v_{DMo}^2}{M_n} \left(1 - \cos(\theta)\right)$$

When $M_n >> M_{DM}$

$$\sim \frac{2M_{DM}^2 v_{DMo}^2}{M_n} = \frac{(2P_{DMo})^2}{2M_n}$$

2 Body Elastic Scatter for Si v_{DM} =232km/s & $\theta = \pi$ 200 500MeV DM Si 180 160 140 Kinetic Energy [eV] 00 00 07 07 60 40 20 0∟ -5 -2 2 ×10⁵ X Momentum [eV/c]

Recoil Energy Scales as M_{DM}^2 . Transfer of DM kinetic energy is really inefficient for elastic 2 Body Scatters when $M_n >> M_{DM}$

Energy Sensitivity Is the Primary Design Driver



Light Mass Dark Matter: Elastic Nuclear Scattering





For DM <~ 200MeV, no ionization expected from NR



Smaller DM masses have less overlap with flat backgrounds!

Light Mass DM Design Drivers: Flat Radiogenic

Are Backgrounds Really Flat?: Coherent **Photon Scattering** 1461keV Photon from ⁴⁰K

 0.1 GeV/c^2 Dark Matter on S Differential cross section $d\sigma/dE_r$ (b/eV) 10⁰ **High Energy Photons can** Ge Coherent Si Coherent 10⁻² coherently elastically He Coherent Ge Compton scatter off nuclei 10⁻⁴ Si Compton May be subject Robinson: 1610.07656 10⁻⁶ to structure effects 10⁻⁸ 10⁻¹⁰ 1610.07656 10⁻³ 10⁻¹ 10^{0} 10^{2}

 10^{-2}

Recoil Energy E_r (eV)

 10^{1}

 10^{3}

Build a Active Photon Veto

Aside: Heavy vs Light Nuclei: Rates

Rate of Elastic Nuclear Recoils Scattering $\sigma = 10^{-41} \text{cm}^2 \text{ M}_{\text{DM}} = 300 \text{ MeV}$





Coherent Vibrational Excitation Regime



Below O(10 MeV), we need to start thinking about DM nucleus interactions in terms of coherent vibrational mode production

Acoustic Phonons



Kinematics: Acoustic Phonon Production



- Characteristic acoustic phonon energy scales as M_{DM} ... not quite as bad as for elastic 2 body recoils
- We should use crystals with really large sound speeds (Sapphire, Diamond,...)



Acoustic Phonon Production from DM



Acoustic Phonon Sensitivity Curves Work In Progress by Griffin, Knapen, Lin, Zurek

- Umklapp processes
- multiphonon excitations



Multiphonon Processes: Offshell 3 body scatters DM can scatter via production of 2 nearly



Acoustic:

Optical:

Due to their gapped nature, optical phonons are kinematically matched to IR and light mass DM!

Knapen, Lin, Pyle, & Zurek: 1712.06598



Optical Phonons: Sensitivity to Scalar Interactions?



- To create an optical phonon, DM needs to push one atom and pull the other ... simple scalar interactions tend to want to pull or push both atoms in the same direction -> sizeable rate suppression ^(S)
- Knapen,Lin,Pyle& Zurek: 1712.06598
- Rajendran et al: 1905.05575

But ... there are an enormous number of crystals with all sorts of optical phonons with different properties.

- High Z and low Z atoms ?
- Optical/Acoustic phonon mixing ?

Work in Progress: Griffin, Knapen, Lin, Zurek

Other DM Interactions?



- Focused on scalar DM interaction so far ...
 - Coherent rate enhancement
 - For supersymmetry and lots of models particularly at high mass, this usually dominates (you need a bit to a lot of fine tuning to have spin or orbital interactions dominate)

For light DM, not so clear ...



- M>1 MeV: Lots of empty parameter space for kg-yr scale experiments!
- M <1 MeV: Lot's of parameter space for simple scalar interacting DM already ruled out by astrophysics and colliders below
Summary: Scalar DM Interactions 1MeV< MeV < 10 GeV

- Design Drivers
 - Exposure
 - Radiogenic backgrounds
 - Energy Threshold
- 2 Body Elastic Scattering -> Coherent Excitations

Dark Sectors and Dark Photons

- Cosmic Visions 1707.04591
- Dark Photon coupling via kinetic mixing is one of the standard well motivated models





Dark Photon Couplings: Polar Crystals

- In ionic crystals, optical phonons are oscillating electric dipoles!
- Very large coupling to photons (black in the IR)... Very large coupling to the dark photons



Sapphire: Lot's of Optical Phonon Bands



Sapphire is a complex crystal with 10 atoms in its unit cell. Dark Matter can interact with lots of different modes

To search for thermal DM down to keV masses via scattering and ultracold bosonic DM to 30 meV, we need a detector sensitive to a single optical phonon





Electronic Excitations

Inelastic e⁻ Recoils in Semiconductors



Detector Requirement: Sensitivity to single e/h pairs with negligible dark count rate

- e- excitation momentum and energy scales in semiconductors well matched to 1 MeV-100MeV DM
- Essig et al: 1108.5383





Potential ER Sensitivity Limits



Problem: Detector Backgrounds in TPCs



Dark Leakage Needs to be Poissonian



N e⁻ background

- N 1e⁻ events occur within detector timing resolution (Poissonian Leakage)
- N e⁻ leakage event (Non-Poissonian Leakage)

Xenon TPCs:

- R_{1e-}=10Hz
- Δt =100ns
- R_{2e} -(Poissonian) = 10⁻⁵Hz

Due to fast timing Xe TPCs can handle a relatively high 1e⁻ rate and still have 2e⁻ bin free. Unfortunately, leakage is non-poissonian (Sorensen: R&D into Xe TPC leakage)

Dark Leakage Rate in Biased Semiconductors





Man vs Nature

- Precision engineering required to have large Efields and no leakage
- Often nature wins $\ensuremath{\mathfrak{S}}$

Si CCDs: Really Good Engineering



DAMIC & SINSEI:

SINSEI (DAMIC): Meets Single e⁻/h⁺ Sensitivity



SINSEI/DAMIC: Dark Current

Dark Current: < 10-3 e/d/pixel (arXiv:1611.03066)

	Number of DC events (100 g y)	
Thr /e	$DC = 1 imes 10^{-3} ext{ e pix}^{-1} ext{day}^{-1}$	$DC = 10^{-5} \text{ e pix}^{-1} day^{-1}$
1	1×10 ⁸	7×10 ⁵
2	2×10 ⁴	0.2
3	3×10 ⁻²	3×10 ⁻⁸

Luke-Neganov (LN) Phonon Amplification

 Drifting charges release kinetic energy via NTL Phonon Production

First Dark Matter Constraints from a SuperCDMS Single-Charge Sensitive Detector



- Average performance during DM search slightly worse due to dilution fridge base temperature variation (this is R&D!)
- Average Baseline Energy Resolution for DM search, <σ> = 14 eV = 0.10 e⁻h⁺

Current ER DM Search Sensitivities



You can do world leading DM searches:

- At the surface
- ½ gd exposure
- SuperCDMS (MP): 1804.10697
- SENSEI: 1901.10478

Building Detectors with Sensitivity to Single Phonons and Single e/h production (without Luke-Neganov Gain)

Optical Phonon Sensitivity -> Low Temperature Detectors

- 300K = 26meV
- To sense single optical phonons we'll need to cool the detector down to near absolute zero
- Use superconducting detector technology
 - MKIDs
 - Transition edge sensors



The Simplest Thermal Calorimeter $\delta T = \frac{\delta E}{C} \bigoplus_{\mathbf{G}} \mathbf{G}$ Bath

Transition Edge Sensor (TES):

- A superconducting metal film (W) that is externally biased so as to be within its superconducting/normal transition
- $\sigma_{\langle E \rangle}^2 = C k_b T^2$
- Must use low Tc and very small volume TES -> hard to get gram-day exposures when your TES (25umx25umx40nm) is 500fg



2nd most simple thermal calorimeter



Couple the sensor to a large volume insulator -> low heat capacity

Problem: Decoupling between the Sensor and Absorber



- Kapitza boundary
- conductance scale as as T³
 - e⁻/phonon thermal conductance scales as T⁴

As T is decreased, it's harder and harder to keep the sensor thermally coupled to the absorber

- Energy leaks out of the absorber through G_{ab} before its measured
- TES sensitive to power fluctuations through G_{tb}

Athermal Phonon Sensor Technology



Collect and Concentrate Athermal Phonon Energy into Sensor



Egw

Excitation Detectors & Volume Scaling



Will these detectors have the same energy sensitivity? Yes, if:

- Lifetime of the athermal excitation (photon) is really long
- Excitation absorption dominated by sensor
- Position Sensitivity





Optimizing the Athermal Phonon Excitation Detectors





Minimize the number/volume of the TES sensors instrumented on the surface to the point that you begin to see the bare surface thermalization rate

Athermal Phonon Thermalization at Surfaces

- Athermal phonon surface thermalization probability found to depend upon
 - Crystal
 - Surface roughness
 - Surface cleanliness

(W. Knaak et al, Phonon Scattering in Condensed Matter V,1986)

- 0.1%-1% of the crystal surface covered with athermal phonon sensors ... 1/1000-1/100 thermalization probability needed
- Si, Ge -> ok



Making Ultra-Sensitive TES



Matt Pyle

For

T. Aramaki, P. Brink, C. Fink, R. Harris, Y. Kolomensky, R. Mahapatra, N. Mirabolfathi, R.Partridge, M. Platt, B. Sadoulet, B. Serfass, S. Watkins

Step 1) Make An Ultra-Sensitive TES



 Build and test simple TES test structures for noise is performance

$$\sigma_{\langle E \rangle}^2 = Ck_b T^2$$

- small volume TES(40nm thick) more sensitive to both DM and environmental backgrounds (RF and vibrations)
- Tc =41 mK

100um x400um TES Characterization



- Simple 2 pole TES dynamical model perfectly fits response
- TES falltime: ~66us (2.4kHz)
 - Relatively fast
 - Long term -> 1ms and allow athermal phonons to ballistically bounce



100um x400um TES Noise

SPIDE

data

Spauld



Frequency [Hz]

nput Referenced Power Noise [W//Hz]

TES R&D

Energy Sensitivity: 50meV -> 1meV

R&D Work Plan

- Lower Tc from 40mK -> 10mK. Since intrinsic theoretical noise, S_p= 4k_bT²G ∝T⁶, energy sensitivity should improve by x4³= x64
- Lower volume by x16, should mean x4 improvement in sensitivity (provided
- Decrease environmental noise susceptibility



Step 2: Make the Athermal Phonon Sensor

- Measured Phonon Collection Efficiency = 20% -> 40% (theoretical limit)
- R&D Work Plan
 - Optimize Collector/TES (W/Al) interface
 - Improve quasi-particle trapping in collector fin



Step 3: Fabricate Sensors on Crystal



Cryogenic Large Area Photon Detectors For Use In Dark Matter Searches and Neutrinoless Double Beta Decay



For

T. Aramaki, P. Brink, J.

Camilleri, C. Fink, R. Harris, Y. Kolomensky, R. Mahapatra, N. Mirabolfathi, R.Partridge, M. Platt, B. Sadoulet, B. Serfass, S. Watkins, T. Yu



Current Progress: Large Area Photon Detector



- 3" diameter Si wafer (45.6 cm²)
- 1mm thick
- Distributed athermal phonon sensors minimize phonon collection time (as fast as it can be for its size)
 - Athermal Phonon collection time estimated to be ~20us
 - 2.5% sensor coverage

Measured Performance: Tc & IV

- T_c= 41.5mK
- IV curves show that the detector and electronics are behaving well
 - Rn = 88 mOhms (300mOhm Expected ... TES too wide!)
 - Rp = 8 mOhms
 - Bias Power $(P_0) = 3.9 \text{ pW}$




Measured Performance: dldV



 TES sensor pretty fast @ 60us. However, it's not as fast as the estimated athermal phonon collection (20us)

- Therefore, we expect phonon signals to have a 20us rise time (athermal phonon collection) and a 60us fall time. Seen for low energy comptons in average pulse shape!
- Pulse shape varies with energy due to local TES saturation.



Measured/Theoretical Noise

Current Noise For R₀ : 32.00 mΩ



Integral Estimators for relative ⁵⁵Fe calibration

 Since pulse shape has significant variation with energy, we must use noisy but minimally biased DC estimators to fit the ⁵⁵Fe calibration lines



Calibrating Pulse Shape Dependent Energy Estimators to the DC estimator (Pulse Tube On)



20gd Surface Dark Matter Search Completed at SLAC



- With a Si Absorber: single e/h sensitivity without Luke-Neganov gain. Can be used for inelastic electronic recoil DM
- World Leading Elastic Nuclear Recoil DM search potential

Prototype Design Estimated Sensitivities

New 1cm³ Prototype Test Design

# TES	100
TES Dimensions	50um x 2um x40 nm
TES Rn	320mOhm
Fin Length	125um
W/Al Overlap	15um
Fractional Al Coverage	1%
Тс	40mK
Bias Power	48fW
Power Noise	5.1e-19 W/rtHz
Phonon absorption time	106us
Sensor fall time	97us
Collection efficiency	19%
σ	219 meV

Summary:

- Design Drivers for 10meV-1GeV DM: Energy Sensitivity
- Athermal Phonon Detectors are a promising technique to search for 10meV-1GeV Dark Matter
- Current Progress:
 - 3" large are photon detector 3.5eV resolution
 - 100x400um TES test chip: 50meV resolution
- R&D Plan: Towards the single quantum regime
 - Increase TES sensitivity: lower Tc
 - Improve Collection efficiency: optimize W/Al interface
 - Fabricate on a variety of crystal substrates
 - Study how phonon surface themalization depends on surface roughness.